Computational Exploration of Anti-Reflective Nanostructures

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Anti-Reflective Coatings:

- The conventional way to reduce reflection from a surface, anti-reflective coatings operate on the principle of interference
- Light is reflected from the front and rear surface of a coating, and destructively interferes with itself (Figure 1)
- For single layer coatings, this is very wavelength-specific (Figure 2)

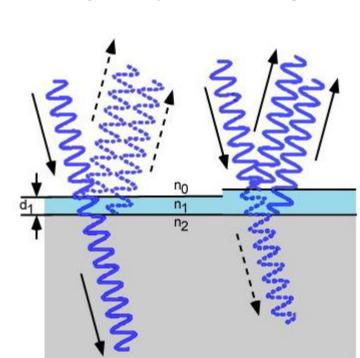


Figure 1: Constructive and destructive interference from a thin-film anti-reflective coating

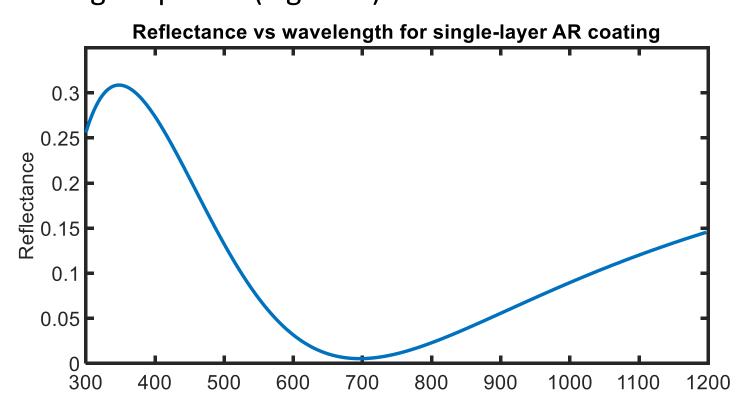


Figure 2: Simulated results for a single-layer thin film, showing a maximum reduction of reflectance for a wavelength of 700nm

Anti-Reflective Nanostructures

• Nanostructures create a refractive index gradient, reducing reflection between infinitesimal "layers"

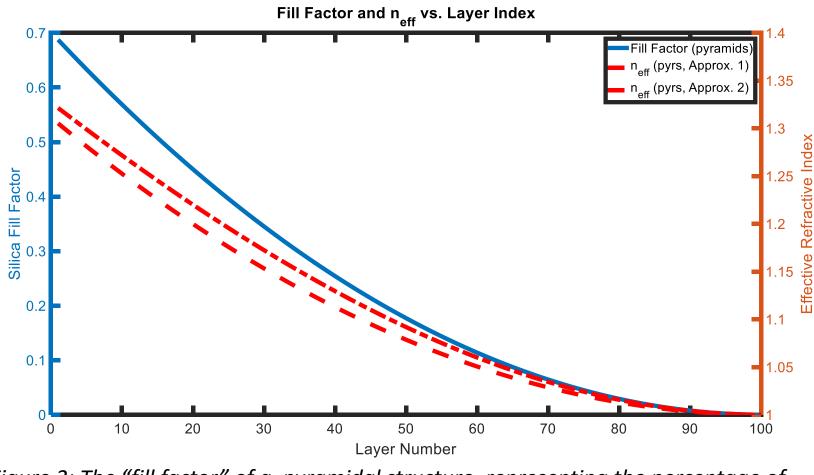


Figure 3: The "fill factor" of a pyramidal structure, representing the percentage of each layer filled by the substrate material, along with two approximations for the effective refractive index

• These structures are discretely simulated, with more layers yielding better results (Figure 4)

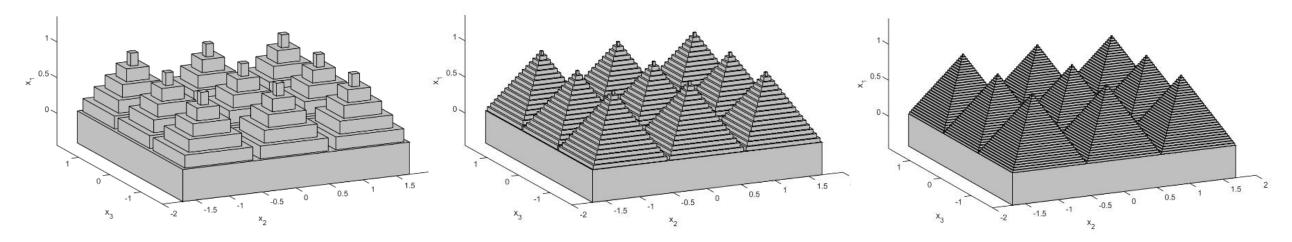


Figure 4: Pyramidal structures modeled using a varying number of layers; note the increasing accuracy with more layers

• Structures can be formed in different shapes, with varying effectiveness (Figure 5)

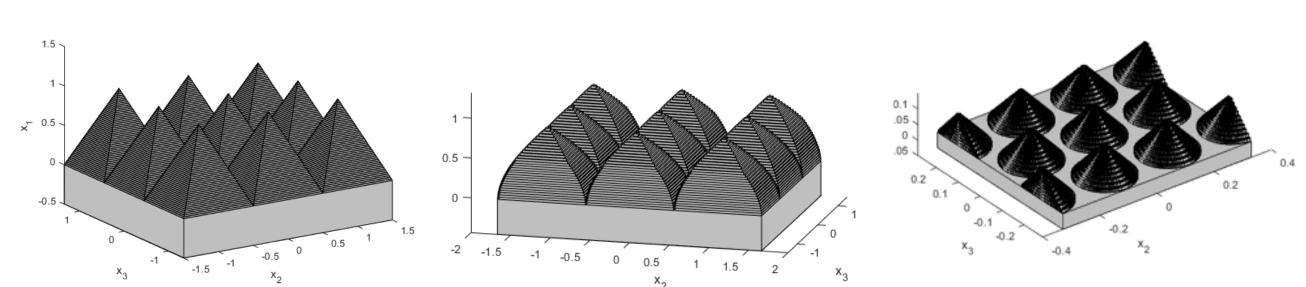


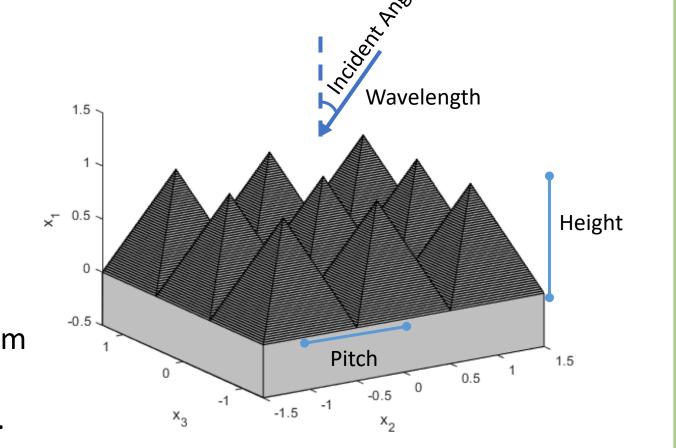
Figure 5: Different possible AR shapes. The aspect ratio, width, and pitch of structures can be changed to yield different results

Evaluation of Structures

- Structure parameters can be "swept" over a range of values to determine an optimum
- In general, the overall structure shape is kept constant while the incident field and structural parameters are changed
- Simulations yield a multidimensional matrix of reflectances

Structural Optimization

- A merit function is used to quantify the optimum structure and field parameters
- A Gaussian blur is used to find "stable" minima.



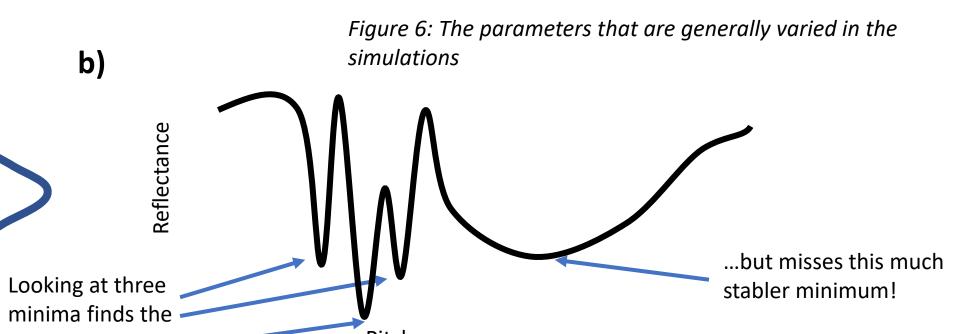


Figure 7: a) An example of the Gaussian blurring process on a two-dimensional matrix b) A two-dimensional representation of the difference between finding absolute minima and stable minima

• The width of the Gaussian blurring function is controlled by a user-specified standard deviation for each parameter; this allows for different parameters to be prioritized

Findings

0.002617 0.000893 0.002703

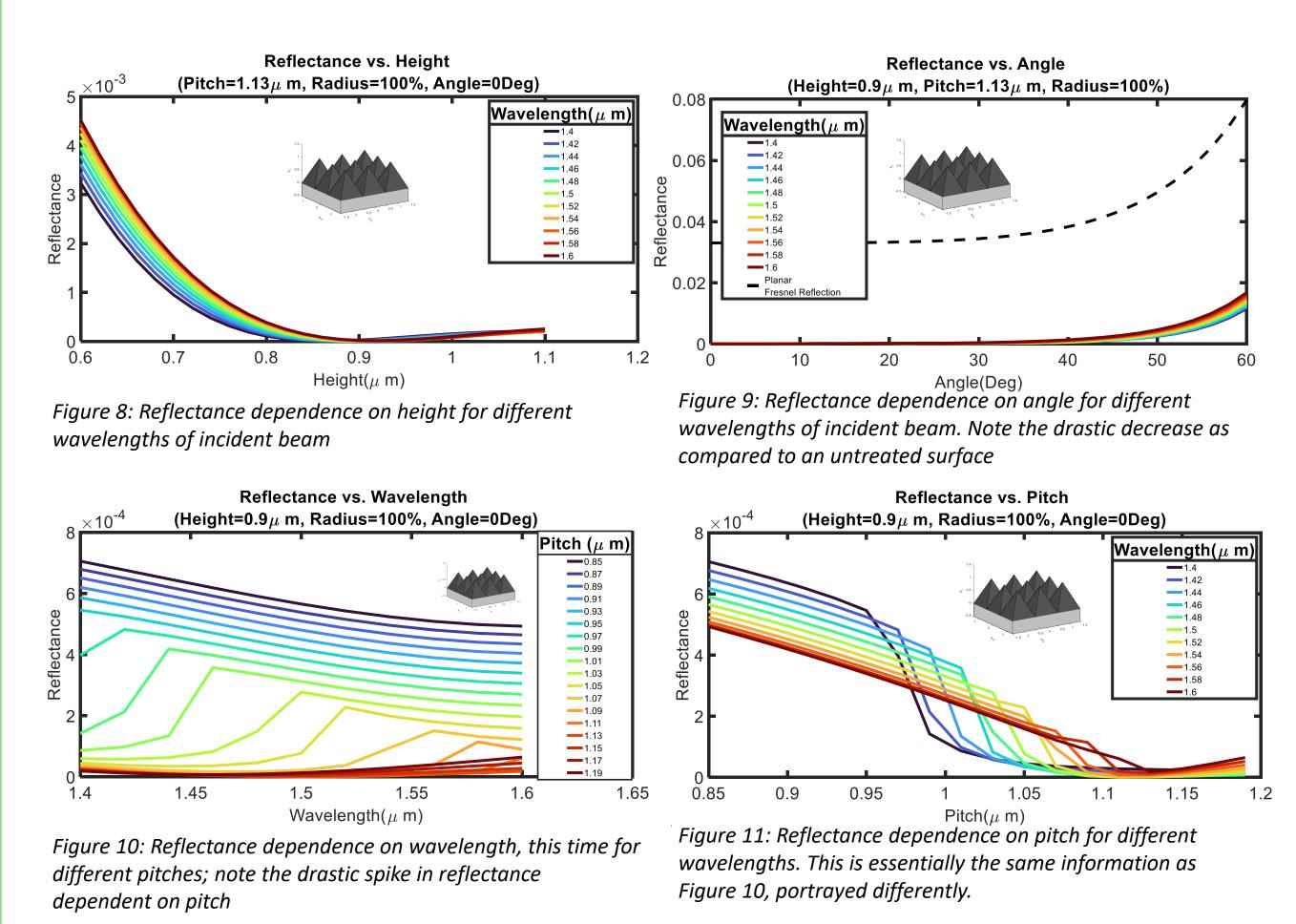
0.00227 0.000882 0.003005

0.001868 0.000912 0.003422

0.001383 <mark>0.001039</mark> 0.004062

Parameter B

- Using the Gaussian blurring merit function, we can optimize each structure to find the configuration with minimal angular sensitivity over the simulated range
- Fused silica around 1550nm was used for all simulations to keep the material consistent
- Reflectance was plotted as a function of several parameters, in order to get a sense of overall behavior



Additional Findings

• As expected, the optimal configuration is different for different structures (Figure 12)

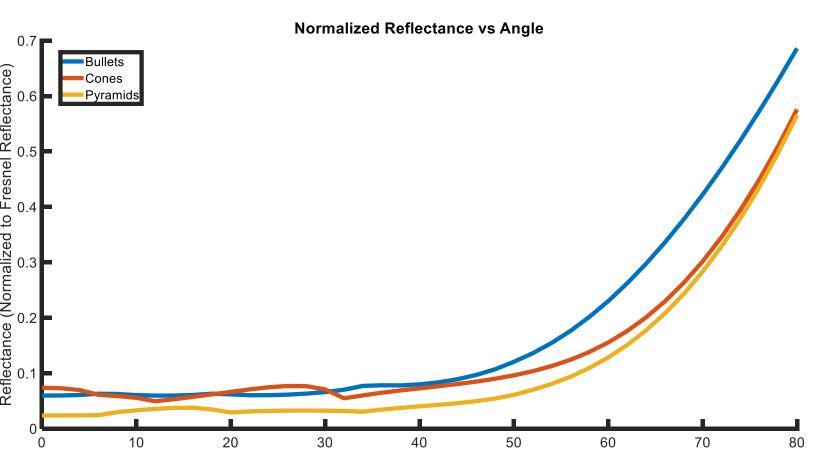


Figure 12: A comparison of reflectance vs angle for three structure shapes, all simulated with identical parameters. Note that the y-axis is normalized. Structures were simulated with a height of $0.9~\mu m$, pitch of $1.13~\mu m$, and $0.19~\mu m$ between bases for a 1500nm beam at normal incidence.

Certain structural shapes perform better across the board as compared to others

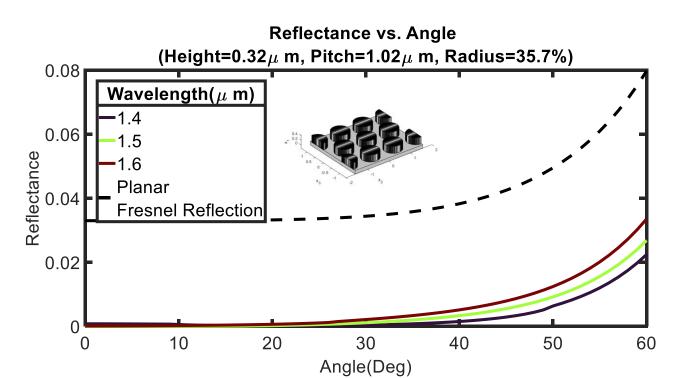


Figure 13: Reflectance dependence on height for different wavelengths of incident beam, this time for cylindrical nanostructures. Note the increased reflectance as compared to pyramidal structures

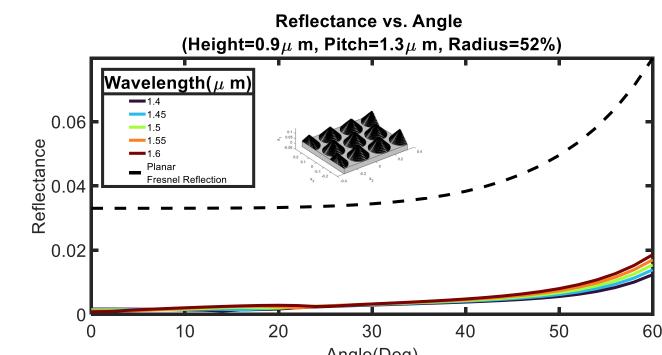


Figure 14: Reflectance dependence on height for different wavelengths of incident beam for conical nanostructures. Note the reflection reduction is relatively comparable to pyramidal results

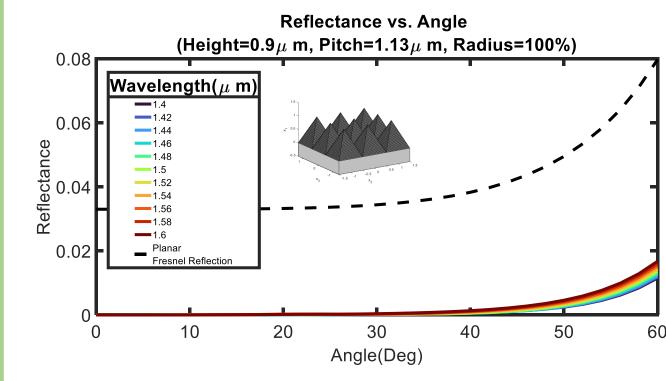


Figure 15: Reflectance dependence on angle for different wavelengths of incident beam. Note the drastic decrease as compared to an untreated surface

Conclusions

- A framework to analyze a set of simulated nanostructures and quickly determine the optimal configuration with regards to minimizing reflectance over a range of parameter values has been developed
- Pyramidal and conical nanostructures show the best performance among the structure shapes analyzed, due to the more gradual transition between air and substrate.
- Future work involves simulating over a wider range of parameter values, as well as altering structure shape.

Acknowledgements

I want to thank Dr. Catherine Jahncke of St. Lawrence University and Dr. Wataru Nakagawa and Jordan Baker of Montana State University for their immense help. I also want to thank Ken Johnson for developing GD-Calc, the simulation software largely used in this project. Finally, the faculty and students of the St. Lawrence physics department deserve acknowledgement for their constant support over the past months.

References

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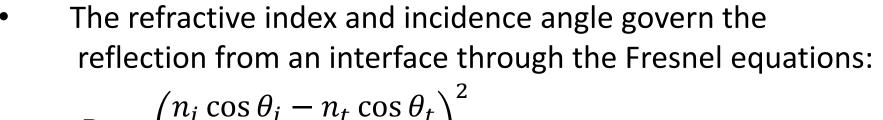
Computational Exploration of Anti-Reflective Nanostructures

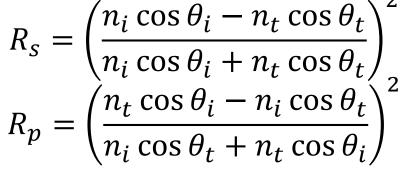
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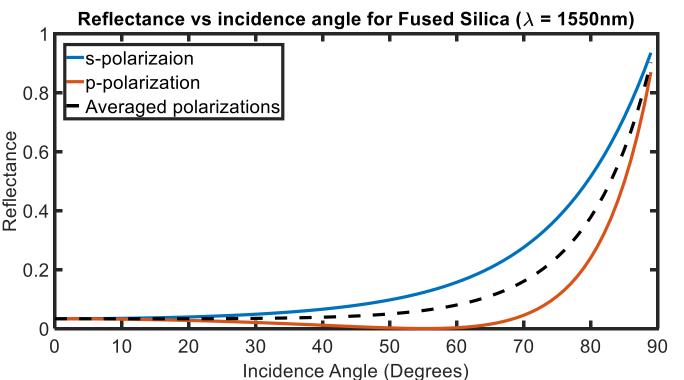
Reflection from an Interface

- Every optical material can be characterized by a refractive index (n)
- The index describes how much light "bends" when entering said material.



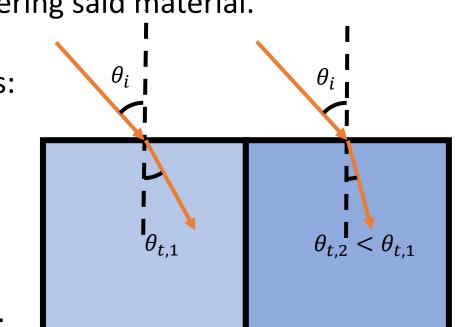


 R_s and R_p denote the reflectance for s and p polarizations; we average these quantities for the remainder of the poster. n_1



Incidence Angle (Degrees)

Figure 1: Reflectance as a function of incidence angle from a simple interface. Note the different values for s- and p- polarizations.



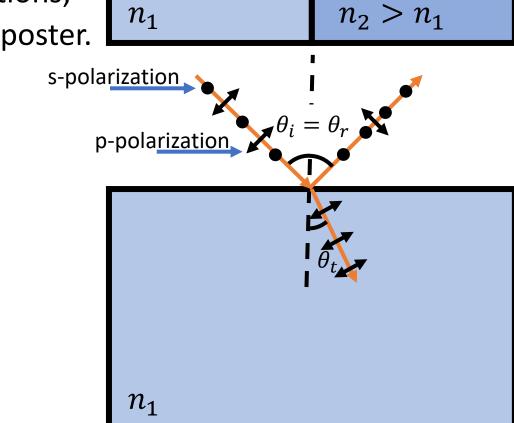


Figure 2: (Top) An image demonstrating the effect of different refractive indices.
(Bottom) The parameters and polarization behavior of reflection.

Interference of Light

- Light can be modeled as a wave, and as such, exhibits interference.
- This interference can be desired, as in the case of antireflective coatings, or undesired, as in the case of backreflection in benchtop optical experiments.

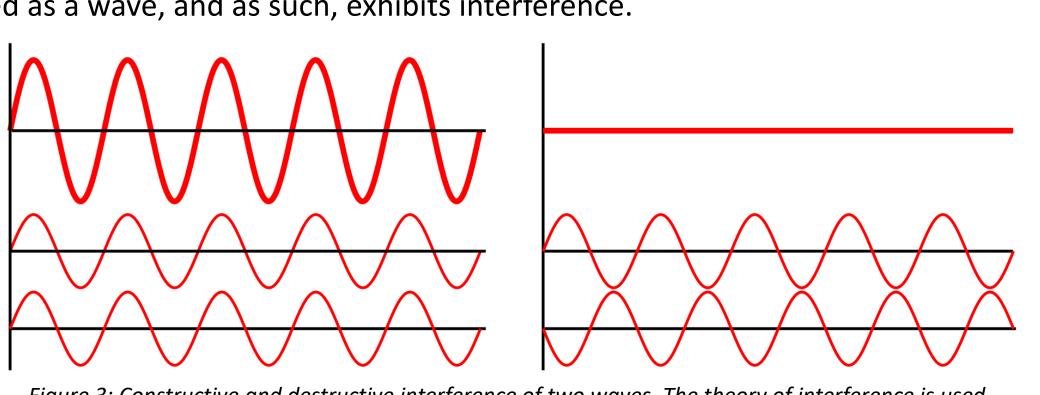


Figure 3: Constructive and destructive interference of two waves. The theory of interference is used in the design of anti-reflective optical coatings, detailed below.

Anti-Reflective Coatings:

- Light is reflected from the front and rear surface of a coating, and destructively interferes with itself (Figure 1)
- For single layer coatings, this is very wavelength-specific (Figure 2)

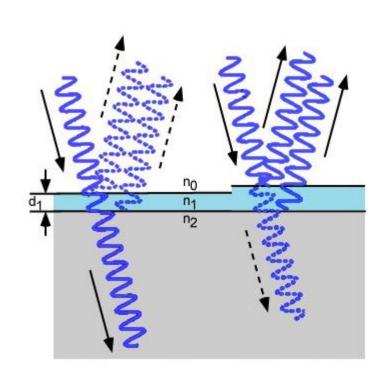


Figure 4: Constructive and destructive interference from a thin-film anti-reflective coating.

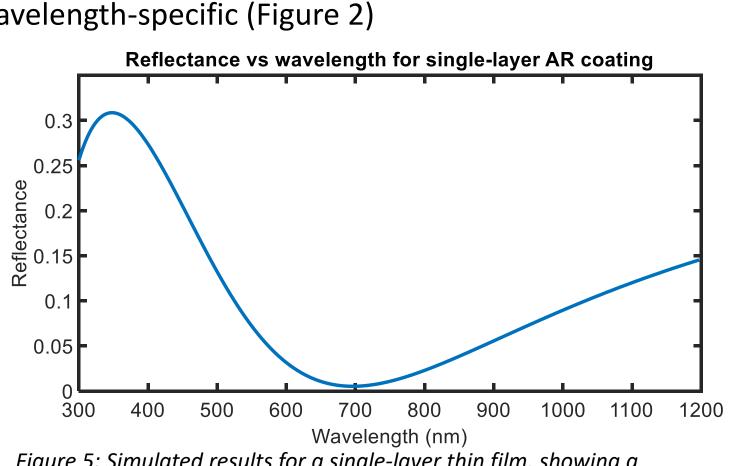


Figure 5: Simulated results for a single-layer thin film, showing a maximum reduction of reflectance for a wavelength of 700nm.

Anti-Reflective Nanostructures

- Nanostructures create a refractive index gradient, reducing reflection between infinitesimal "layers"
- The lack of reliance on interference means that they have the potential to perform better over wide angular or wavelength ranges
- We largely investigate the performance of AR nanostructures over a wide angular range Fill Factor and n ... vs. Layer Index

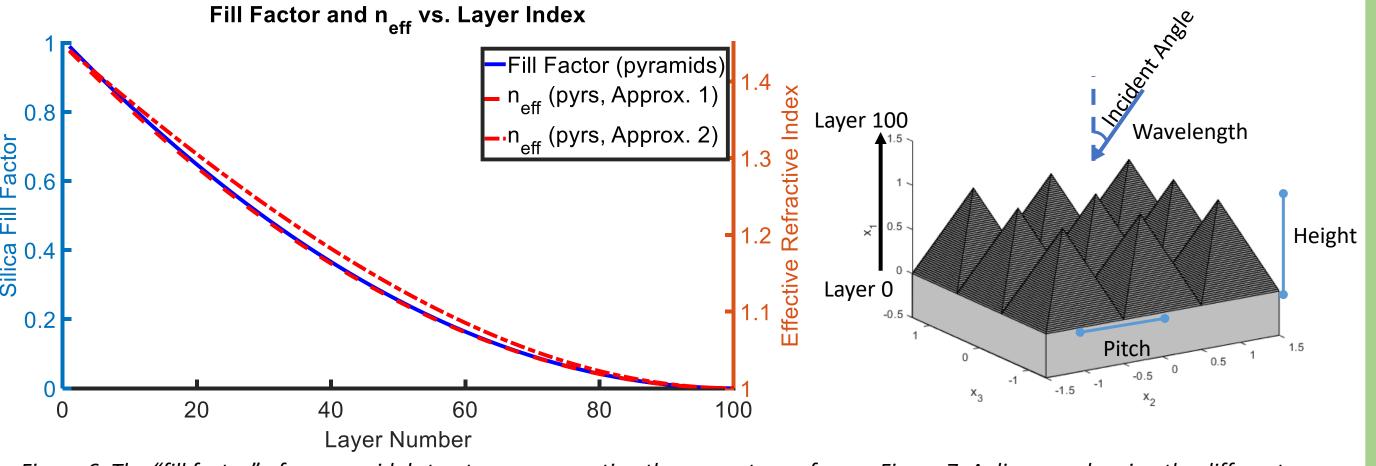


Figure 6: The "fill factor" of a pyramidal structure, representing the percentage of each layer filled by the substrate material, along with two approximations for the effective refractive index.

Figure 7: A diagram showing the different parameters that were varied for each shape.

• Structures can be formed in different shapes, with varying effectiveness (Figure 8)

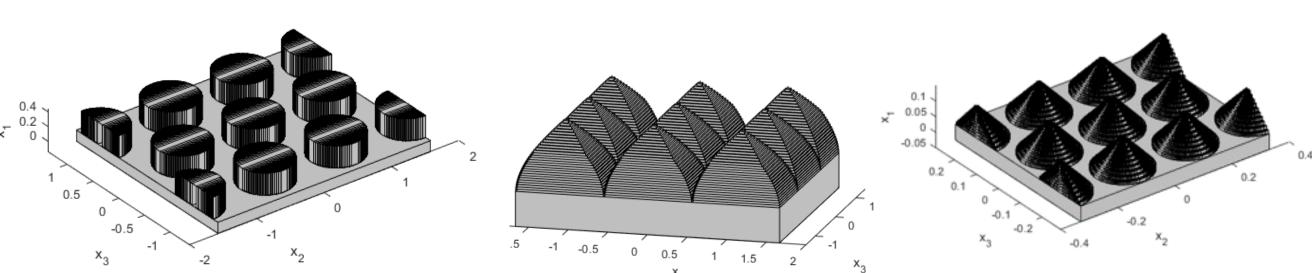


Figure 8: Different possible AR shapes. The aspect ratio, width, and pitch of structures can be changed to yield different results.

Each shape has a different fill-factor curve, yielding different effective refractive index profiles
 Fill Factors vs Layer Index

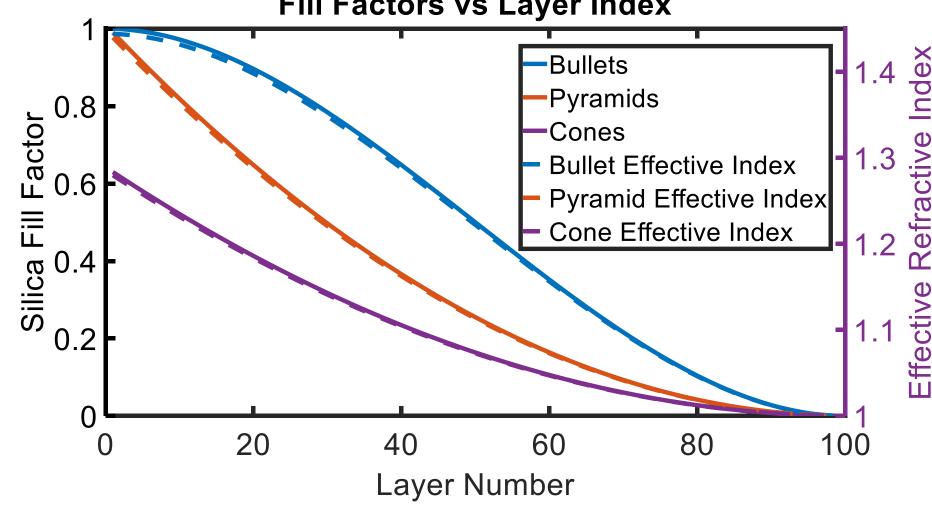


Figure 9: Fill factors and approximate effective refractive indices for three different structure shapes.

The "smoothest" effective index transition surprisingly does not yield the best results!

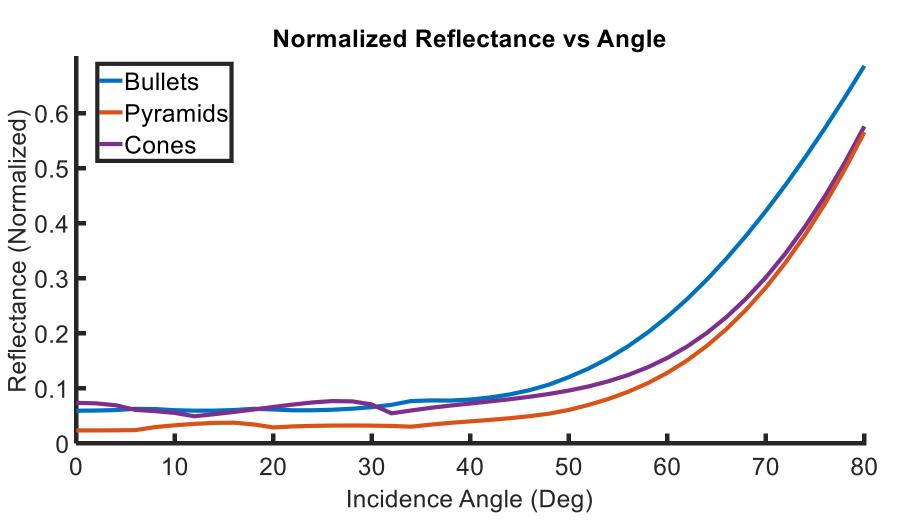


Figure 10: A comparison of reflectance vs angle for three structure shapes, all simulated with identical parameters. Note that the y-axis is normalized to the "baseline reflectance"; that is, the reflectance of a flat pane of fused silica. Structures were simulated with a height of $0.9 \mu m$, pitch of $1.13 \mu m$, and $0.19 \mu m$ between bases for a 1500nm beam at normal incidence.

Findings

- Results, such as those in Figure 10, were obtained through the use of the MATLAB simulation package GD-Calc
- Fused silica was used for all simulations to keep the material consistent.
- The input wavelength was around 1550nm for all simulations.
- Reflectance was plotted as a function of several parameters, in order to get a sense of overall behavior
- The following figures demonstrate that the optimization of these structures is a multifaceted problem. Even considering a single structure shape, reflectance varies widely based on structure pitch and height.

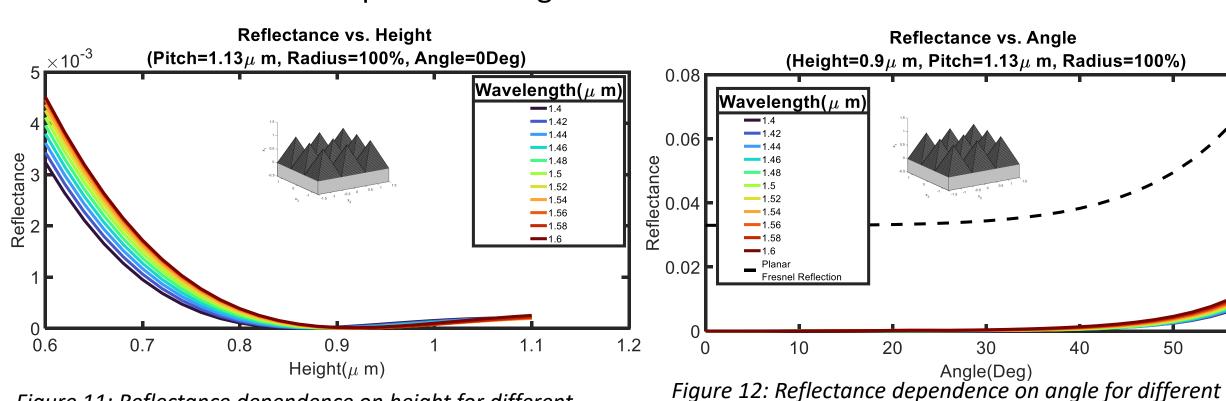
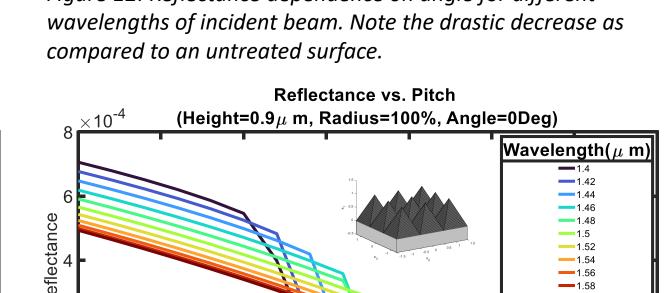


Figure 11: Reflectance dependence on height for different wavelengths of incident beam.

Reflectance vs. Wavelength

(Height=0.9 μ m, Radius=100%, Angle=0Deg



Wavelength(μ m) Figure 13: Reflectance dependence on wavelength, this time for different pitches; note the drastic spike in reflectance dependent on pitch.

0.85 0.9 0.95 1 1.05 1.1 1.15 Pitch(μ m)

Figure 14: Reflectance dependence on pitch for different wavelengths. This is essentially the same information as Figure 10, portrayed differently.

Conclusions

- A framework to analyze a set of simulated nanostructures and quickly determine the optimal configuration with regards to minimizing reflectance over a range of parameter values has been developed
- Future work involves simulating over a wider range of parameter values, as well as altering structure shape.
- Bullet-shaped structures show promise, due to the smoother transition in effective refractive index. However, in the structure ranges simulated, they have shown to be inferior to pyramids.
- The problem of finding an "optimum solution" that minimizes reflectance for a given situation is complex and multi-faceted and requires the use of an iterative process to find an optimum for a specific situation.

Acknowledgements

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